
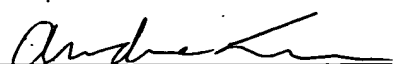


FORM PTO-1449  INFORMATION DISCLOSURE CITATION IN AN APPLICATION  <div style="text-align: center;">  </div>				DOCKET NUMBER SLA 1028		SERIAL NUMBER 10/003,800	
				APPLICANT Andrew R. Ferlitsch			
				<b>RECEIVED</b> MAR 05 2002 2624 AL Technology Center 2600			
FILING DATE: 10/23/2001				GROUP ART UNIT 2624 AL			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FIL. DATE IF APPROP.	
AL	5982996	11/9/1999	Snyders	395	114	3/13/1997	
AL	5528734	6/18/1996	Sanchez	395	115	5/31/1994	
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AL	5845058	12/1/1998	Shaw et al.	395	114	11/20/1996	
AL	6,248,996	06/19/2001	Johnson et al.	250	234	07/12/1999	
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AL	<del>04-199218</del>	<del>07/20/1992</del>	<del>Japan</del>			<del>Abstract</del>	
AL	<del>10-031750</del>	<del>02/03/1998</del>	<del>Japan</del>			<del>Abstract</del>	
AL	<del>10-207643</del>	<del>08/07/1998</del>	<del>Japan</del>			<del>Abstract</del>	
AL	<del>11-024860</del>	<del>01/29/1999</del>	<del>Japan</del>			<del>Abstract</del>	
AL	<del>2000-151873</del>	<del>05/30/2000</del>	<del>Japan</del>			<del>Abstract</del>	
AL	<del>64-014043</del>	<del>01/18/1989</del>	<del>Japan</del>			<del>Abstract</del>	
AL	<del>2000-099303</del>	<del>04/07/2000</del>	<del>Japan</del>			<del>Abstract</del>	
AL	<del>05-270064</del>	<del>10/19/1993</del>	<del>Japan</del>			<del>Abstract</del>	
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AL	<del>11-015608</del>	<del>01/22/1999</del>	<del>Japan</del>			<del>Abstract</del>	
AL	<del>10-340167</del>	<del>12/22/1998</del>	<del>Japan</del>			<del>Abstract</del>	
AL	<del>11-143661</del>	<del>05/28/1999</del>	<del>Japan</del>			<del>Abstract</del>	
AL	<del>10-340166</del>	<del>12/22/1998</del>	<del>Japan</del>			<del>Abstract</del>	
AL	<del>2000-132347</del>	<del>05/12/2000</del>	<del>Japan</del>			<del>Abstract</del>	
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